

forming the passivation film consisting of chromium oxide by  
5 applying heat treatment in an oxidizing atmosphere after coating  
chromium on the metallic material of [which] the surface  
roughness (Ra) of [a coat] metallic material surface is not more  
than [1.5im] 1.5μm.


4. (Amended) [Parts contracting with fluid and a] A fluid  
supplying/exhaust system for manufacturing semiconductors,  
comprising metallic material having a chromium-oxide passivation  
film according to claim 1.

IN THE ABSTRACT

Please delete the abstract on file and replace it with the  
attached ABSTRACT OF THE DISCLOSURE.

If the Examiner has any questions or comments that would  
speed prosecution of this case, he is invited to call the  
undersigned at 219/485-6001.

Respectfully submitted,

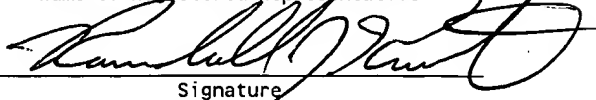
  
Randall J. Knuth  
Registration No. 34,644

RJK/jrw  
Encs: Clean Claims  
Replacement  
ABSTRACT OF THE DISCLOSURE  
Return Postcard  
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Randall J. Knuth, Regis. No. 34,644

Name of Registered Representative

  
Signature  
July 13, 2001  
Date